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U.S. DEPARTMENT OF COMMERCE
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LIST OF ART CITED BY APPLICANT
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09/784,234

APPLICANT
Shozo Nagano et al.

FILING DATE
February 14, 2001

GROUP
1742

U.S. PATENT DOCUMENTS

*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
C3	AA	4,189,084	02-1980	Johnson et al.			
	AB	09/550,488		J. Kardokus (Amendment dated 7-10-01)			04-21-2000
	AC	09/714,714		J. Kardokus (Amendment dated 6-22-02)			11-15-2000
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						

FOREIGN PATENT DOCUMENTS

		Document Number	Date	Country	Class	Subclass	Translation	
							Yes	No
C3	AL	85104006	01-1986	China (abstract)				
C3	AM	62036798	08-1987	Japan (abstract)				
C3	AN	61227972	10-1986	Japan (abstract)				
C3	AO	49007777	02-1974	Japan (abstract)				
C3	AP							

OTHER REFERENCES (including Author, Title, Date, Pertinent Pages, Etc.)

C3	AR		Reda et al., "Amorphous copper-silver films with high stability", Int. Cent. Theor. Phys., Trieste, Italy, 1983. (Abstract only) The year is sufficiently early so that the month is not in issue.
C3	AS	"	U.S. patent application, 09/556,488, Kardokus, filed 4/21/00
C3	AT	"	U.S. patent application, 09/714,714, Kardokus, filed 2/14/01

EXAMINER S. Ip

DATE CONSIDERED 12/15/02

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.